



1FW

Docket No.: P2000,0361

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No. : 10/609,464
Applicant : Wolfgang Dickenscheid, et al.
Filed : June 27, 2003
Art Unit : 2123
Title : Method for Characterizing and Simulating a Chemical
Mechanical Polishing Process
Docket No. : P2000,0361
Customer No. : 24131

STATUS LETTER

Commissioner for Patents,
P.O. Box 1450, Alexandria, VA 22313-1450

Sir:

It is respectfully requested that this Status Letter be returned to:

LERNER AND GREENBERG, P.A.
Post Office Box 2480
Hollywood, FL 33022-2480
Tel: (954) 925-1100
Fax: (954) 925-1101

with an indication as to when an action may be expected.

Respectfully submitted,

Alexia J. Vrahimis

Date: January 14, 2005

/av